



PATENT  
Customer No. 2872  
Attorney Docket No. 8071.0007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Takeshi MITSUISHI et al. ) Group Art Unit: 2872  
Application No.: 09/986,907 ) Examiner: Joshua Pritchett  
Filed: November 13, 2001 )  
For: COMPOSITION FOR VAPOR )  
DEPOSITION, METHOD FOR )  
FORMING AN ANTIREFLECTION )  
FILM, AND OPTICAL ELEMENT )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

REPLY

This reply is filed in response to the non-final Office Action of March 24, 2003.  
Prompt and favorable reconsideration of this application in light of the remarks below is respectfully requested.

REMARKS

Claims 1-17 remain pending in this application. Applicants acknowledge, with appreciation, the indication that claims 3-8 are directed to allowable subject matter, and would be allowable if rewritten in independent form.

To the extent that claims 9-17 depend, either directly or indirectly, on the subject matter of claims 6 or 8, we believe that these claims also should have been indicated to be allowable. A process of making an antireflection film from a composition that is both

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FINNEGAN  
HENDERSON  
FARABOW  
GARRETT &  
DUNNER LLP

1300 I Street, NW  
Washington, DC 20005  
202.408.4000  
Fax 202.408.4400  
[www.finnegan.com](http://www.finnegan.com)